

03500.013974.1



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TADAHIRO OHMI ET AL.

Application No.: 09/985,707

Filed: November 6, 2001

For: LASER GAS SUPPLY PATH
STRUCTURE IN AN
EXPOSURE APPARATUS
(AS AMENDED)

Examiner: Davienne N. Monbleau

Group Art Unit: 2828

August 26, 2002

#4/B
EOT
(DM)

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT AND PETITION FOR EXTENSION OF TIME

Sir:

Applicants petition for a one-month extension of time from July 24, 2002 to and including August 24, 2002 (Saturday) to extend the time for response to the outstanding Office Action dated April 24, 2002. A check in the amount of \$110.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, and credit any overpayment, to Deposit Account 06-1205.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on

August 26, 2002

(Date of Deposit)

PETER SAXON

(Name of Attorney for Applicant)

August 26, 2002

Signature

Date of Signature

09/03/2002 MAHMED1 00000023 09985707

01 FC:115
02 FC:102

110.00 OP
84.00 OP